

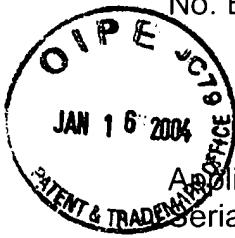
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PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Chang Bum Kim, et al.

Art Unit 1765

Serial No. 10/054,629

Filed January 22, 2002

Confirmation No. 5778

For **LOW DEFECT DENSITY SILICON HAVING A VACANCY-DOMINATED CORE
SUBSTANTIALLY FREE OF OXIDATION INDUCED STACKING FAULTS**

Examiner Matthew A. Anderson

January 16, 2004

**PRELIMINARY AMENDMENT A AND
RESPONSE TO RESTRICTION REQUIREMENT**

TO THE ASSISTANT COMMISSIONER OF PATENTS,

SIR:

In response to the Office Action mailed December 17, 2003, Applicants submit the following Preliminary Amendment A and Response to Restriction Requirement.

PRELIMINARY AMENDMENT A

Please enter the following amendments to the claims, as reflected in the listing of the claims that begins on page 2 of this paper. Remarks related to these amendments begin on page 4 of this paper.